



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 6, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG646485292

Report verification at [igi.org](#)

PROPORTIONS

Medium

64%

14%

48.5%

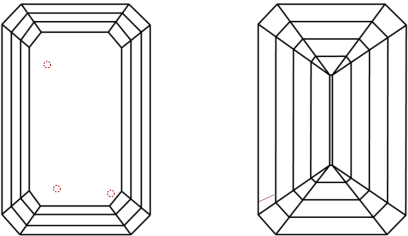
66.8%

Long



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VVS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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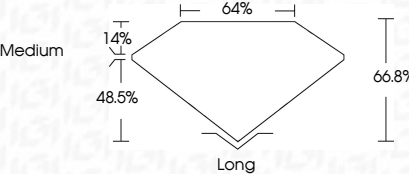
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IGI Report No LG646485292

EMERALD CUT

8.23 X 5.87 X 3.92 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.87 CARAT

E

VS 2

66.8%

64%

Medium

Long

EXCELLENT

EXCELLENT

NONE

IGI LG646485292

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